



Application of:

MINEO SHIMOTSUSA, ET AL.

Application No.: 10/657,269

Filed: September 9, 2003

For: SEMICONDUCTOR DEVICE, METHOD FOR
MANUFACTURING THE SAME, AND LIQUID
JET APPARATUS

Docket No. 03500.016072.1

Examiner: Long Pham

Group Art Unit: 2814

Date: October 13, 2004

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

☐ No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	35	MINUS	34	= 1	x \$9 \$18	\$18.00
INDEP. CLAIMS	7	MINUS	7	= 0	x \$44 \$88	\$0.00
Fee for Multiple Dependent claims \$150/\$300						\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$18.00

☐ Verified Statement claiming small entity status is enclosed, if not filed previously.

☒ A check in the amount of \$ 18.00 is enclosed.

☐ Charge \$_____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.

☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.

☐ A check in the amount of \$_____ to cover the fee for a _____ month extension is enclosed.

☐ A check in the amount of \$_____ to cover the Information Disclosure Statement fee is enclosed.

☒ Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Daniel S. Glueck
Attorney for Applicants
Registration No.: 37,838

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200

DSG/k/m

Form #120

DC_MAIN 181129v1



IFW

03500.016072.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	
MINEO SHIMOTSUSA, ET AL.)	Examiner: Long Pham
	:	
Application No.: 10/657,269)	Group Art Unit: 2814
	:	
Filed: September 9, 2003)	
	:	
For: SEMICONDUCTOR DEVICE,)	
METHOD FOR	:	
MANUFACTURING THE SAME,)	
AND LIQUID JET APPARATUS	:	October 13, 2004

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

Introductory Comments

In response to the Official Action dated September 13, 2004, please amend
the above-referenced application as follows:

10/14/2004 HLE333 00000052 10657269

01 FC:1202

18.00 0P